

## Alabama Plasma Internship Program (ALPIP)

## **Project Title:**

Plasma-catalysis effects on LCF Perovskite Ion Transport Membrane processing of CH<sub>4</sub>

#### **Project Reference Code:**

UA-Uddi

## **Hosting Institution:**

University of Alabama-Tuscaloosa

#### **Hosting Institution Location:**

Tuscaloosa, AL

#### **Project Description:**

**Plasma-Catalysis:** study the Plasma-Catalysis (PC) effect of non-equilibrium low temperature plasma on ceria nano-catalysts to produce different chemicals (syngas- $CO + H_2$ ) using CO<sub>2</sub>, CH<sub>4</sub>, air as feedstock, at 1 atm pressure, in the temperature range 400-900 C, through experiments. The effect of plasma on the surface reactions is to be studied.

**Method:** Assemble a home built reactor to test ceria nano-powder with RF discharge will be used. Various types of optical/ laser diagnostics of the plasma-surface interaction will be done. Optical diagnostics includes plasma emission spectroscopy, plasma imaging with high speed ICCD camera, PLIF-Planar Laser Induced Fluorescence etc. The exhaust gases will be analyzed for temporal species composition using a Quadrupole Mass Spectrometer (QMS).

#### Disciplines:

Chemistry, Math, Engineering

#### U.S. citizenship required to participate in this project

## Name(s) of Mentor(s) and contact information:

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The name and contact information of personnel at the hosting is provided for further assistance with questions regarding the hosting institution or the project.

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